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APPLICANTS

William Andrew Nevin, Partadown, IRELAND;
 Paul Damien McCann, Jordanstown, IRELAND;

** CONTINUING DATA *NONE PD*

** FOREIGN APPLICATIONS *NONE PD*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>Examiner's Signature</i> <i>PD</i> Initials	STATE OR COUNTRY IRELAND	SHEETS DRAWING 6	TOTAL CLAIMS 49	INDEPENDENT CLAIMS 3
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ADDRESS

Matthew E. Connors
 Gauthier & Connors LLP
 Suite 3300
 225 Franklin Street
 Boston, MA
 02110

TITLE

Method for forming a cavity and an SOI in a semiconductor substrate, and a semiconductor substrate having a buried cavity and/or an SOI formed therein

FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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